

FIG. 1  
(Prior Art)

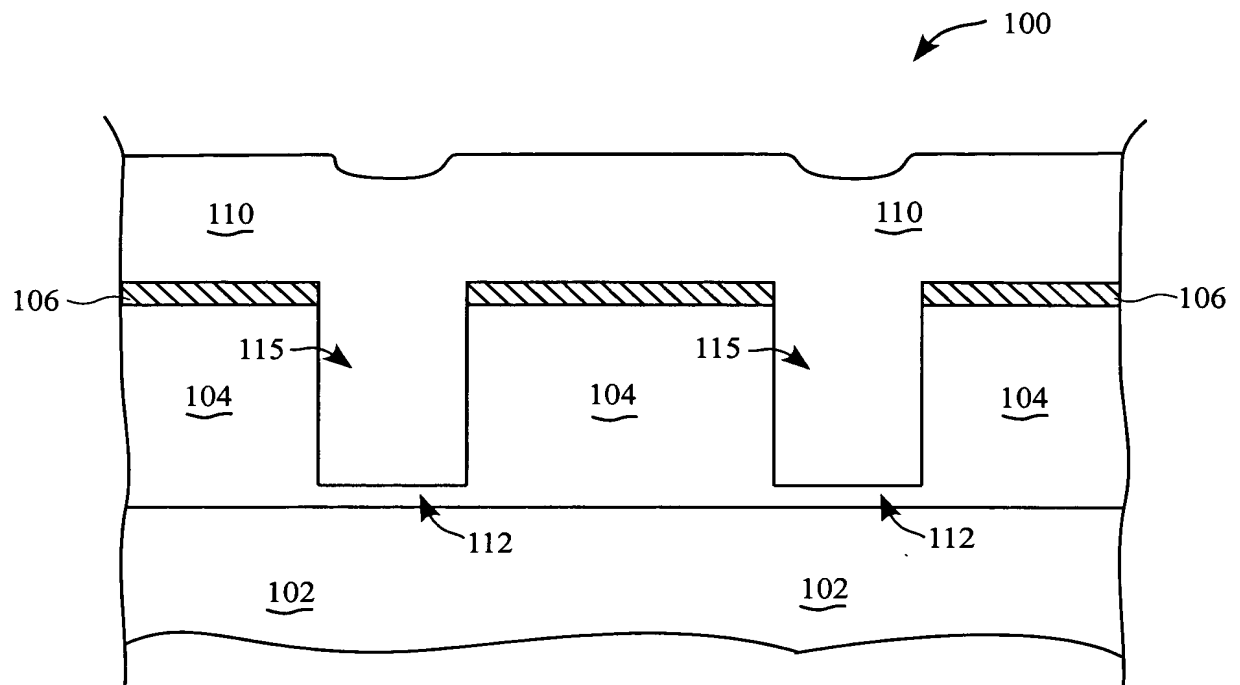


FIG. 2A

Title: METHOD FOR MANUFACTURING A RECLAIMABLE TEST PATTERN  
WAFER FOR CMP APPLICATIONS

Application No.: 09/752,610

Docket No.: LAM2P221

Inventor: LACY

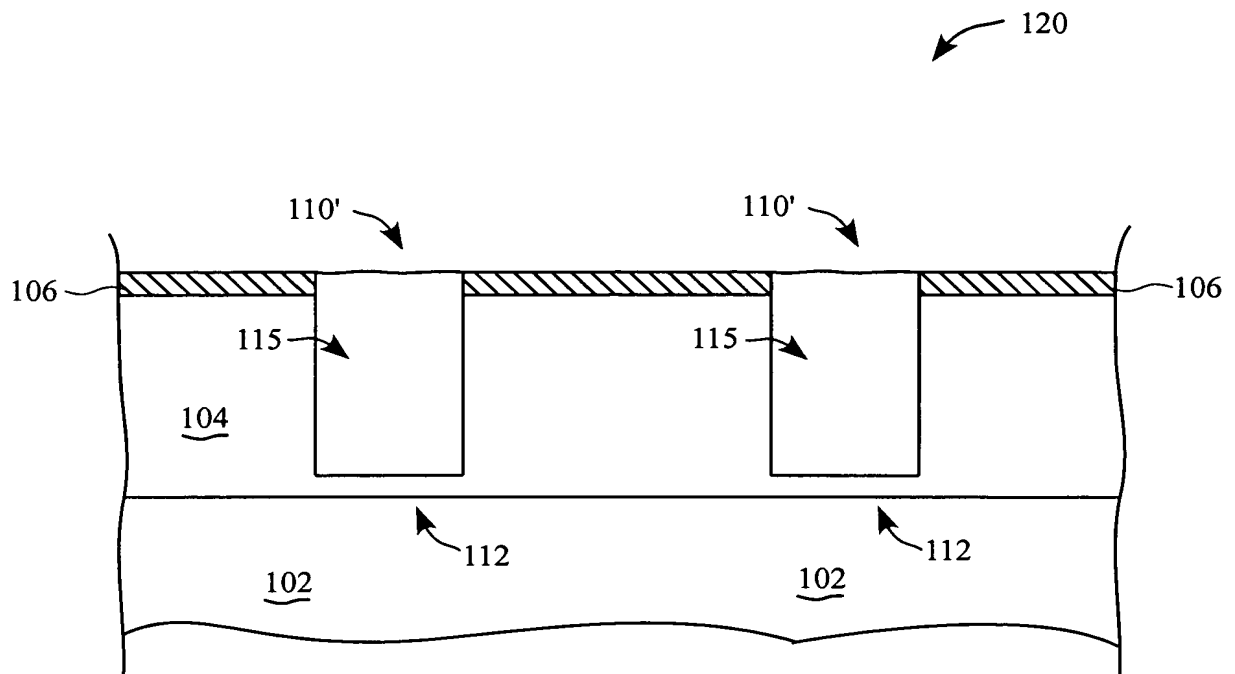


FIG. 2B



FIG. 2C

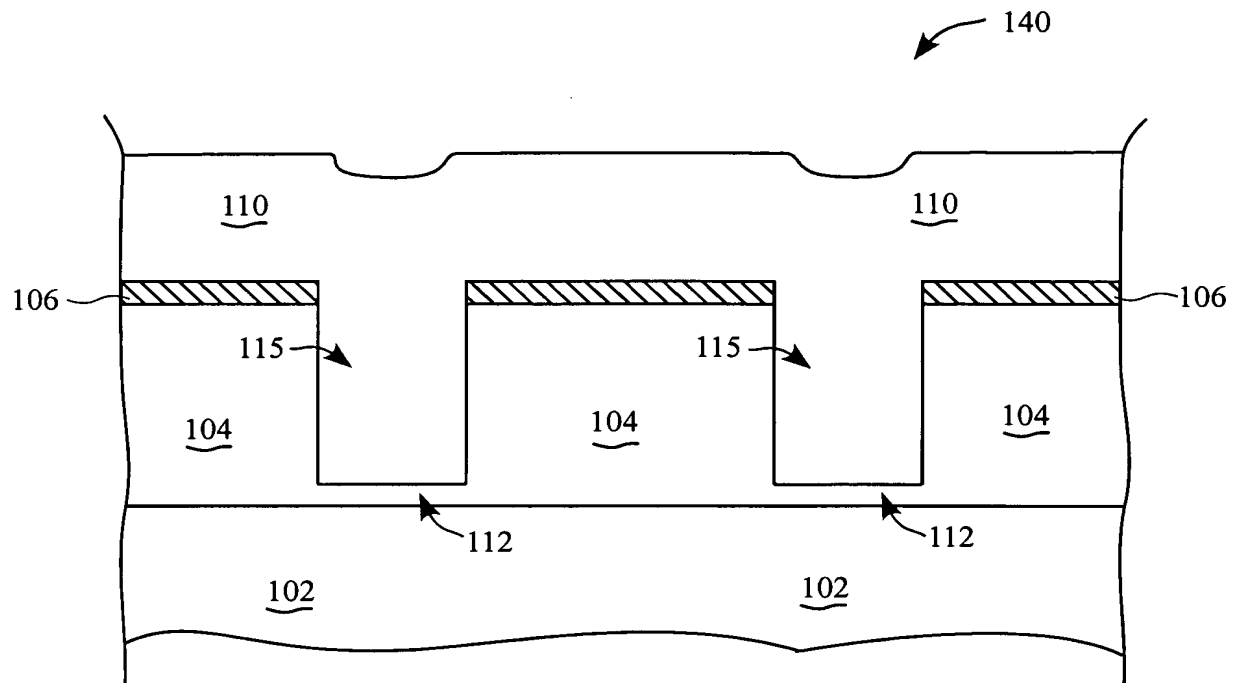


FIG. 2D

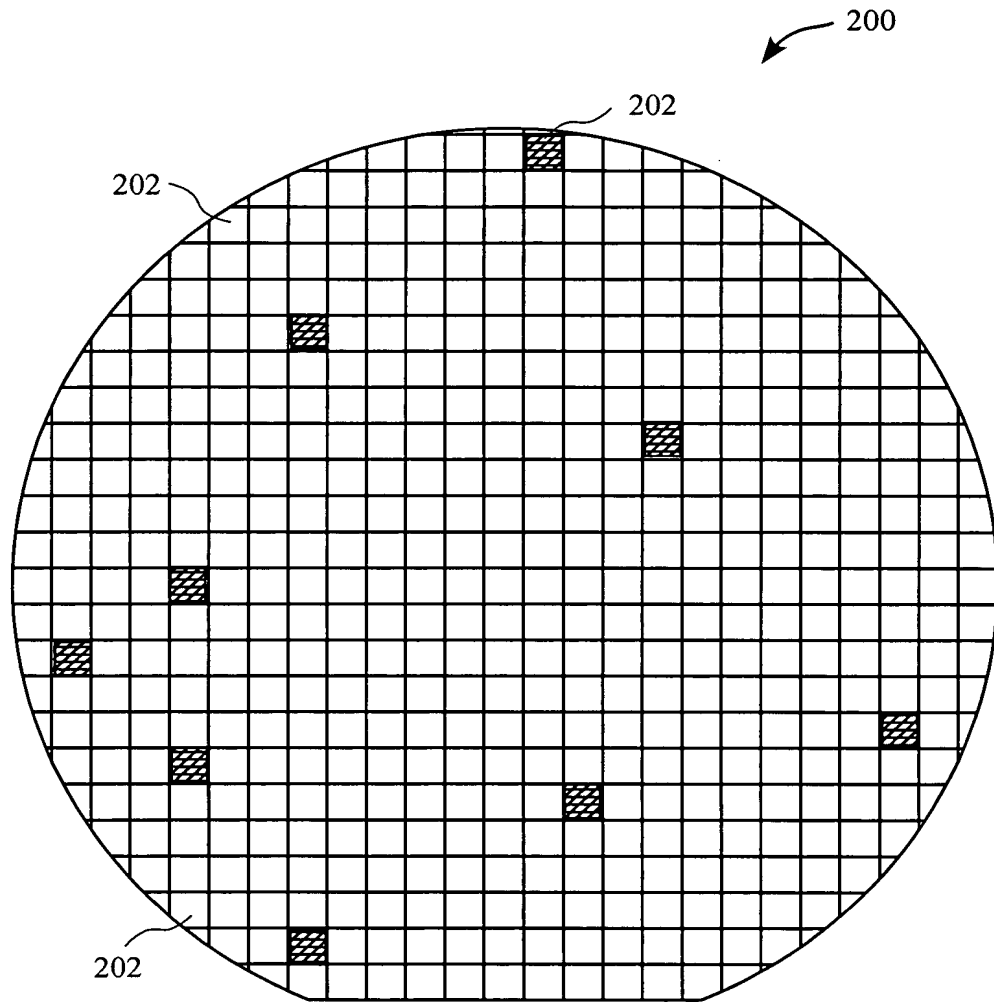


FIG. 3A

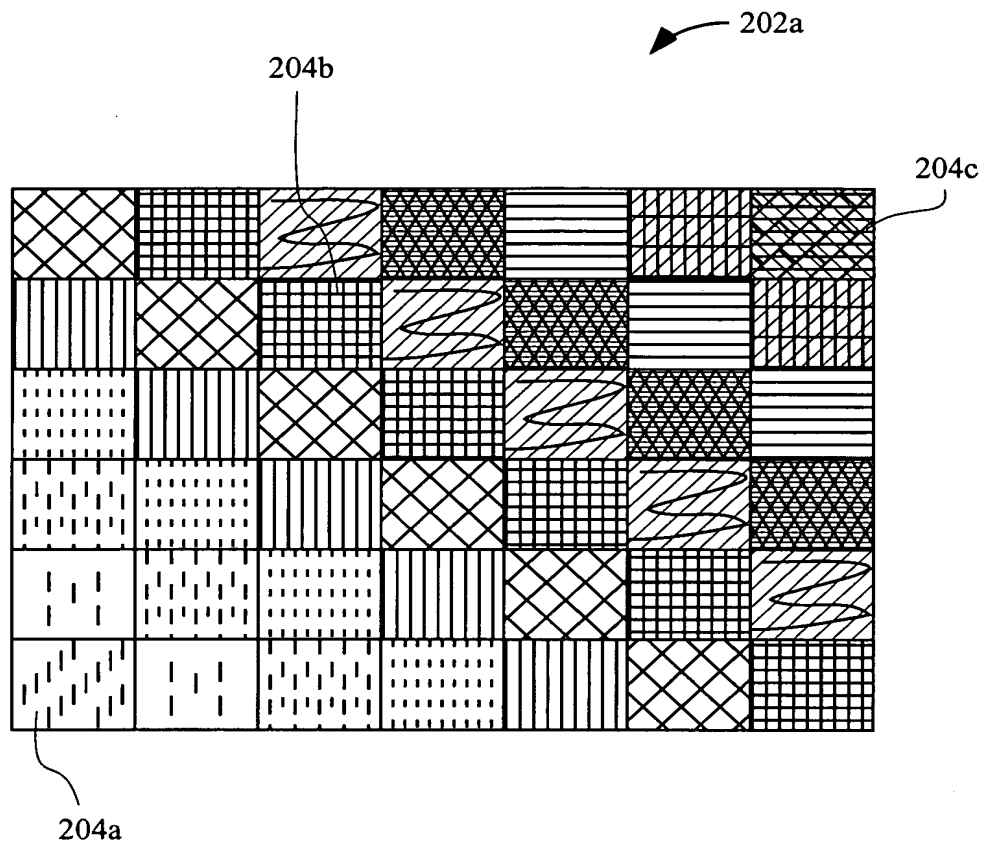


FIG. 3B

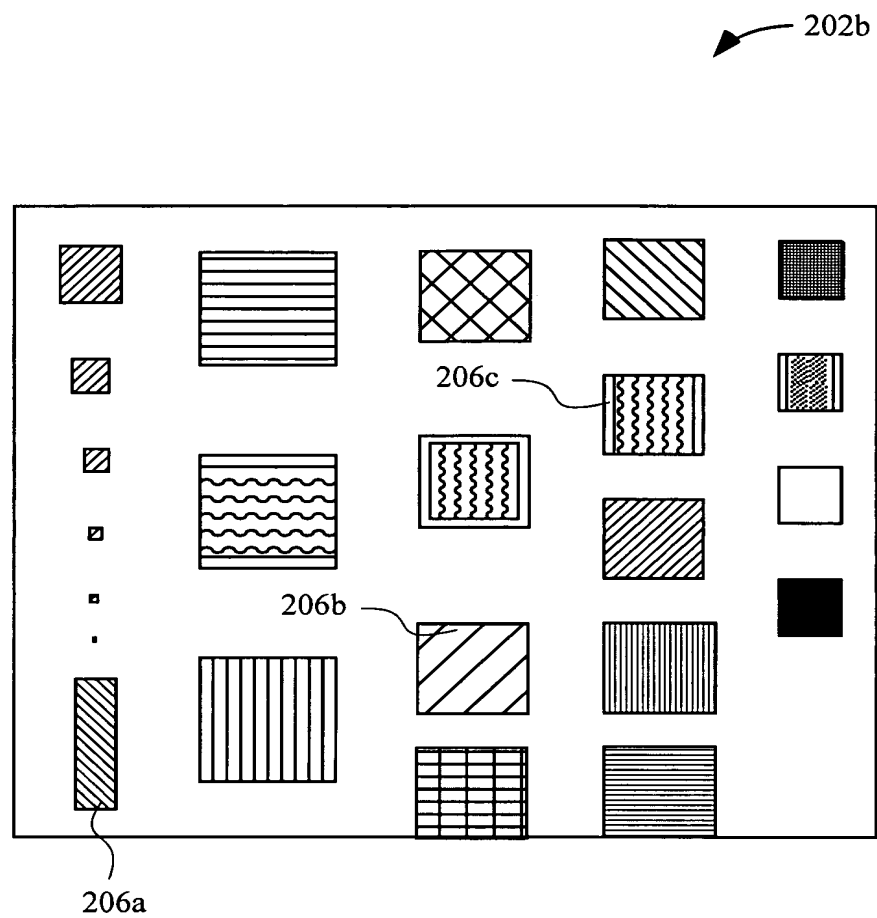


FIG. 3C



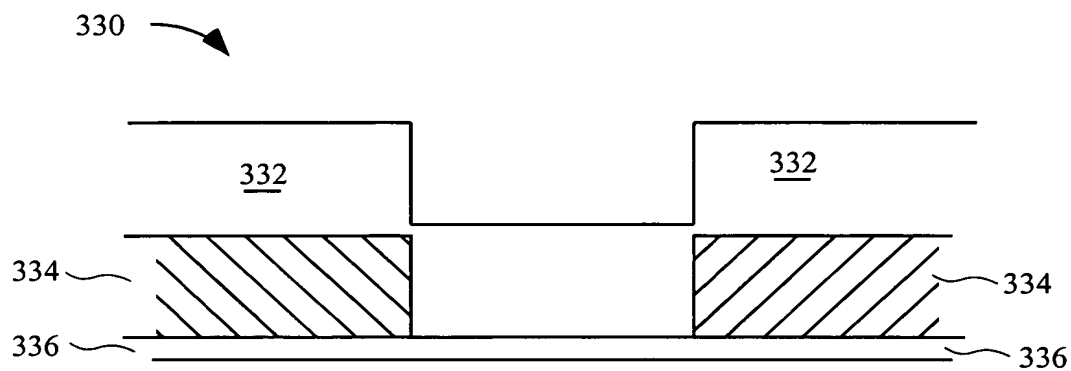


FIG. 4A

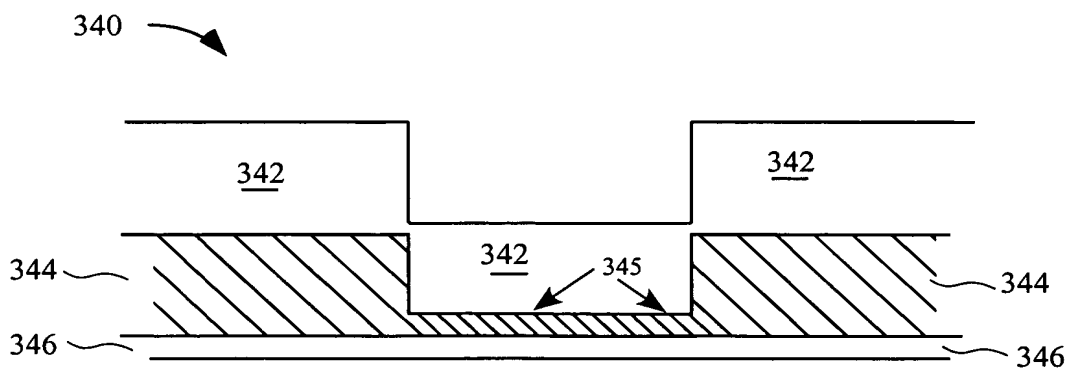


FIG. 4B

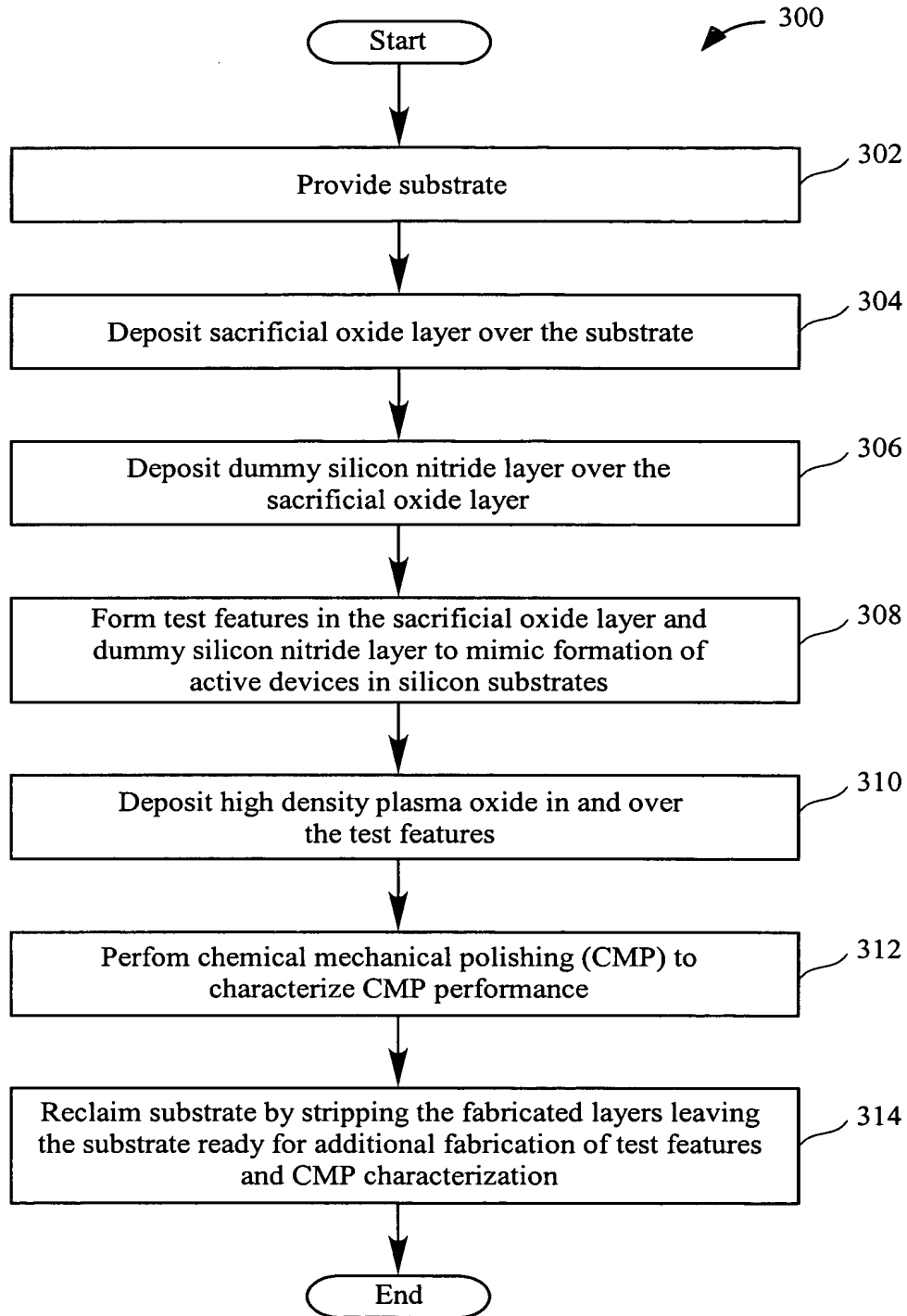


FIG. 5